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Applicant: Vaartstra

Appl. No.: 10/229,802

Filing Date: August 28, 2002

U.S. Patent No.: 6,794,284

Issue Date: September 21, 2004

Title: SYSTEMS AND METHODS FOR FORMING REFRACTORY METAL NITRIDE LAYERS USING DISILAZANES

Attorney Docket No.: 150.01280101

Pub. No.: US 2004/00043604 A1

Pub. Date: March 4, 2004

This is in response to the request for correction of patent application publication under 37 CFR 1.221(b), which was filed on March 4, 2004.

The request is DISMISSED as moot.

The instant request identifies numerous errors in the published patent application publication. Since the application has already issued as U.S. Patent No. 6,794,284 on September 21, 2004, the request is deemed moot.

Inquiries relating to this matter may be directed to the undersigned at (571) 272-7709.

Mark O. Polutta
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